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Sheet Subst. Form PTO-1449 Docket Number (Optional) Application Number CVXV-001CN 08/920,044 FORMATION DISCLOSURE CITATION Applicant IN AN APPLICATION W. Lincoln Bouve et al. Filing Date Group Art Unit (Use several sheets if necessary) August 28, 1997 U. S. Patent Documents EXAMINER FILING DATE DOCUMENT NUMBER DATE NAME CLASS SUBCLASS MO 4,972,319 11/20/90 Delorme 364 419 wo 5,030,117 07/09/91 Delorme 434 130 MA 5,155,806 10/13/92 395 157 Hoeber et al. W 5,243,528 09/07/93 Lefebvre 364 449 5,289,572 02/22/94 Yano et al. 395 155 5,398,186 03/14/95 Nakhla 364 428 06/13/95 5,424,951 Nobe et al. 364 443 5,452,240 09/19/95 705.06 364 Roca et al. 5,461,708 10/24/95 395 140 Kahn FOREIGN PATENT DOCUMENTS Translation DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) EXAMINER DATE CONSIDERED EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.

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Applicant

W. Lincoln Bouve et al.

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